

# 3<sup>rd</sup> International Workshop on Advanced Atomic Force Microscopy Techniques

March 5-6, 2012

Karlsruhe Institute of Technology (Campus North)

Organizers:

Hendrik Hölscher (Institute of Microstructure Technology, KIT)

Thomas Schimmel (Institute of Nanotechnology, KIT)

Invited Speakers:

Wilhelm Barthlott (University of Bonn)

József Fortágh (University of Tübingen)

Ricardo Garcia (IMM Madrid)

Stanislav Gorb (CAU Kiel)

Armin Knoll (IBM Zürich)

Egbert Oesterschulze (TU Kaiserslautern)

Pascal Ruffieux (EMPA)

Abstract Submission:

Contributed talks and posters will be accepted till January 31, 2012. Please send your one-page abstract as a PDF-file via email to [hendrik.hoelscher@kit.edu](mailto:hendrik.hoelscher@kit.edu).

Registration:

Please register by sending the registration form to [hendrik.hoelscher@kit.edu](mailto:hendrik.hoelscher@kit.edu). The number of attendees is limited. The registration fee for the workshop is 100 €. A reduced fee for students is available at 50 €. Deadline for registration is February 19, 2012.

Accommodation:

Rooms are available at the Renaissance Karlsruhe Hotel at the special rate of €91 for a single or €110 for a double room. As the contingent is limited, we recommend making your reservation as early as possible by contacting the hotel directly at the following address: [Renaissance Karlsruhe Hotel](#), Mendelssohnplatz, 76131 Karlsruhe, Tel.: +49 721 3717-381, Fax: +49 721 3717-333. To receive the special rates, which both include breakfast, mention the code "AFM-Workshop".

Best Poster Award:

A Best Poster Award of 300 €, 200 €, and 100 € will be granted to the authors of the three best poster presentations by SPECS Surface Nano Analysis GmbH.

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For further information please visit our web-page [www.imt.kit.edu/afm.php](http://www.imt.kit.edu/afm.php) or contact:

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